

<b>Notice of References Cited</b>	Application/Control No. 10/633,111		Applicant(s)/Patent Under Reexamination ZHANG ET AL.	
	Examiner JEREMIAH C. HUBER		Art Unit 2621	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,130,984	07-1992	Cisneros, Arturo	370/399
*	B	US-5,742,361	04-1998	Nakase et al.	375/240.26
*	C	US-5,606,369	02-1997	Keesman et al.	375/240.01
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U	offset. (2009). In Merriam-Webster Online Dictionary. Retrieved August 31, 2009, from <a href="http://www.merriam-webster.com/dictionary/offset">http://www.merriam-webster.com/dictionary/offset</a>			
	V				
	W				
	X				

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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